

PATENT
Attorney Docket No.: DF-04500

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:) Group Art Unit:
Min-Hon Rei et al.) Examiner:
Serial No.:) **INFORMATION DISCLOSURE**
Filed: herewith) **STATEMENT**
For: **METHOD FOR FORMING**
SUPPORTED PALLADIUM
MEMBRANE USED FOR
HYDROGEN PURIFICATION) 162 N. Wolfe Road
) Sunnyvale, CA 94086
) (408) 530-9700
) Customer No.: 28960

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The citations listed below, copies attached, may be material to the examination of the above-identified application, and are therefore submitted in compliance with the duty of disclosure defined in 37 C.F.R. §§ 1.56 and 1.97. The Examiner is requested to make these citations of official record in this application.

Applicants have become aware of the following printed publications which may be material to the examination of this application:

- U.S. Patent No. 6,152,987;
- Taiwan Patent No. 400307;
- Japan Patent No. 2002-119834;
- Japan Patent No. 2002-153740; and
- Japan Patent No. 3-288534.

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This Information Disclosure Statement under 37 C.F.R. §§ 1.56 and 1.97 is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that anyone or more of these citations constitutes prior art.

Respectfully submitted,
HAVERSTOCK & OWENS LLP

Dated: March 10, 2004

By: 
Jonathan O. Owens
Reg. No.: 37,902

Attorneys for Applicants

FORM PTO-1449 (Modified)		U.S. Department of Commerce Patent and Trademark Office INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use Several Sheets If Necessary) (37 CFR § 1.98(b))	Attorney Docket No.: DF-04500		Serial No.: Not yet available
			Applicant: Min-Hon Rei et al.		
			Filing Date: herewith		Group Art Unit:

U.S. PATENT DOCUMENTS

Examiner Initials		Serial / Patent Number	Issue Date	Applicant / Patentee	Class	Subclass	Filing Date
	AA	6,152,987	11/28/00	Ma et al.	95	56	08/24/98
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						

FOREIGN PATENTS OR PUBLISHED FOREIGN PATENT APPLICATIONS

		Document Number	Publication Date	Country / Patent Office	Class	Subclass	Translation	
							Yes	No
	AK	400307	12/15/87	TW	C01B	3/24		X
	AL	2002-119834	04/23/02	JP	C01B	3/56		X
	AM	2002-153740	05/28/02	JP	C23C	18/31		X
	AN	3-288534	12/18/91	JP	C01B	3/56		X
	AO							
	AP							
	AQ							
	AR							
	AS							

OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication)

AT	
AU	
AV	
AW	
AX	
AY	
AZ	
BA	
BC	
BD	
BE	
BF	

Examiner:

Date Considered:

EXAMINER: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.